

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Dae-Woong KANG et al.

Serial No.: 10/758,802 Examiner: Warren, Matthew E.

Filed: January 15, 2004 Group Art Unit: 2815

Confirmation No.: 6500

For: METHODS OF FABRICATING A SEMICONDUCTOR DEVICE
HAVING MULTI-GATE INSULATION LAYERS AND
SEMICONDUCTOR DEVICES FABRICATED THEREBY

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, Paper No. 20080609, dated July 8, 2008, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.